



INFORMATION DISCLOSURE STATEMENT PTO Form 1449	Docket Number 01760.0001-US-01	Serial Number 10/601090
	Applicant(s) VISCOR et al.	
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U.S. PATENT DOCUMENTS

EXAMINER INITIALS	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE (IF APPROPRIATE)

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS

<i>12</i>		Poppeller et al., "Hot Electron Emission Lithography", <u>Applied Physics Letters</u> , Vol. 73, No. 19, November 9, 1998, pp. 2835-2837.

Examiner: <i>ZIA R. HASHMI</i>	Date Considered: <i>4/19/04</i>
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